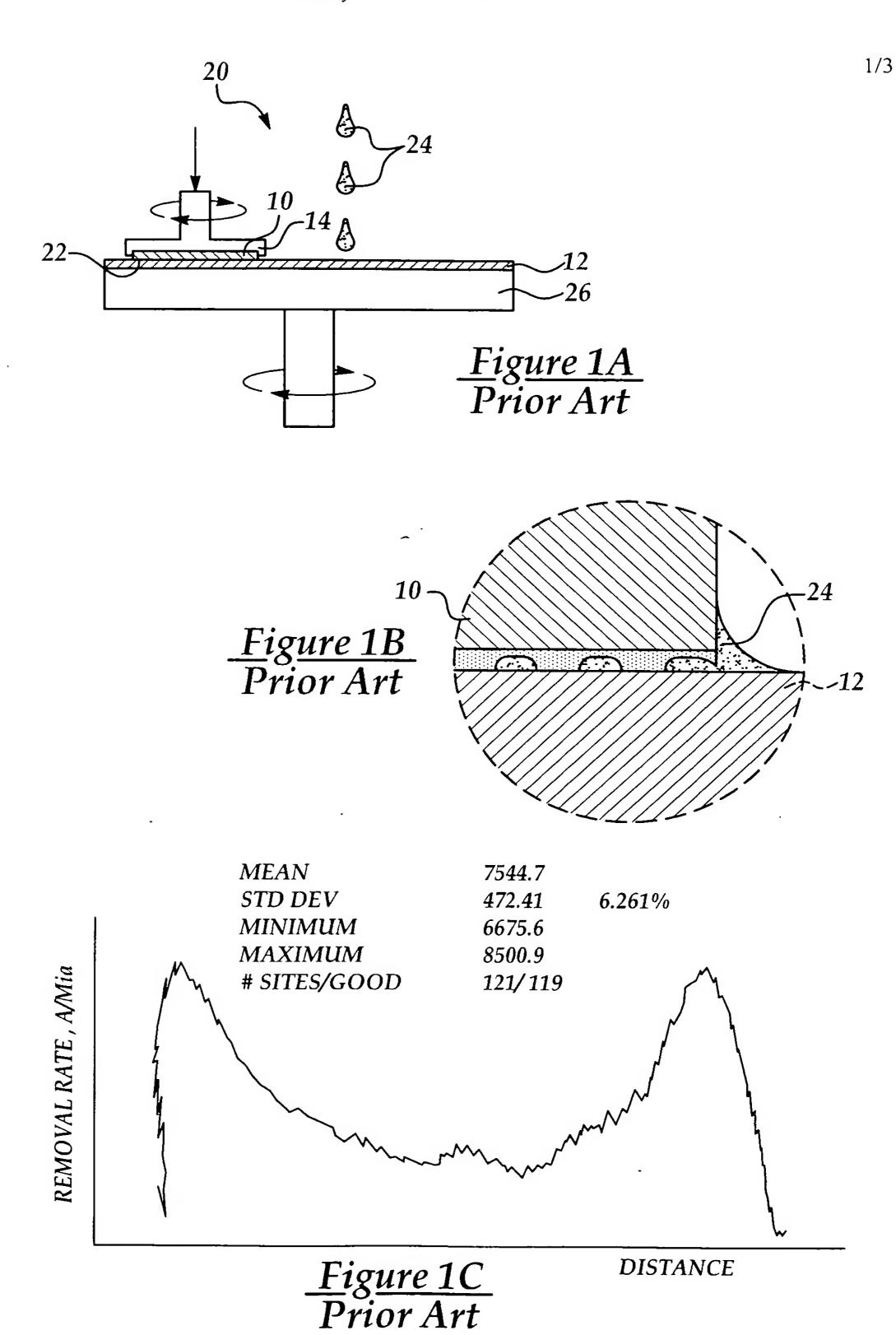
Inventor: Chia-Che Chuang Serial No.: To Be Assigned Filed: Herewith

For: Apparatus and Method for Pre-Conditioning CMP Polishing Pad

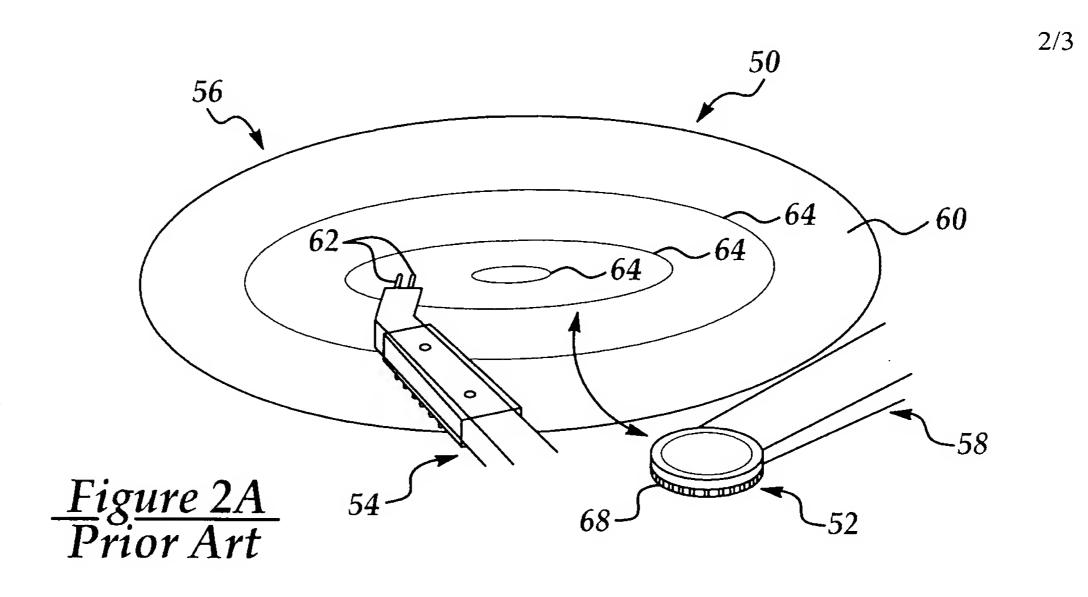
Attorney Doc. No.: 67,200-1131

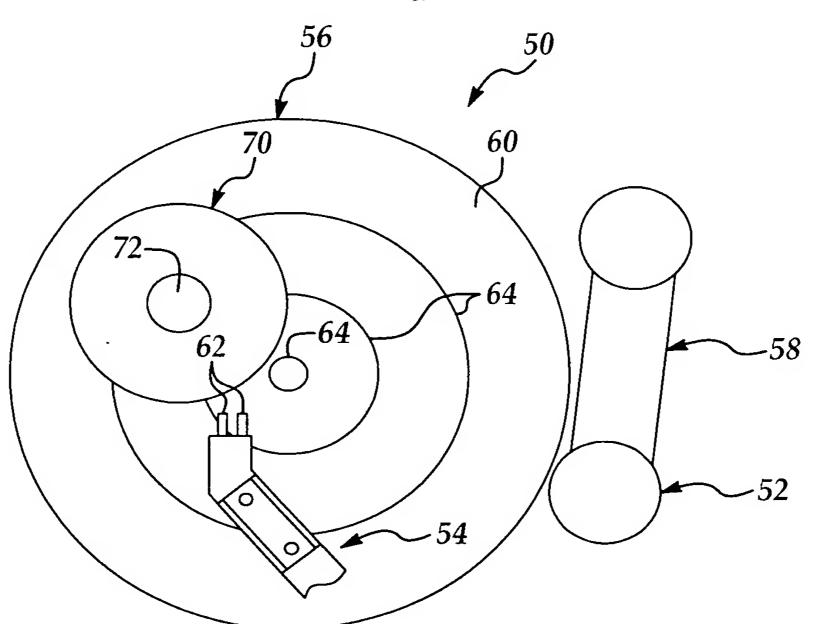


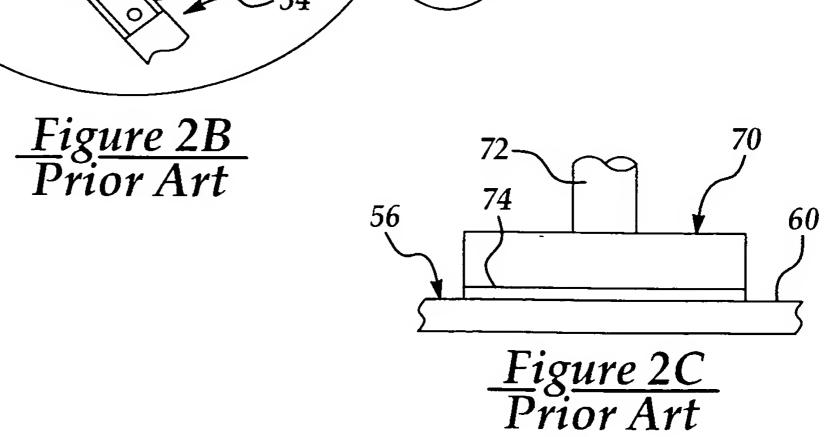
Inventor: Chia-Che Chuang Serial No.: To Be Assigned Filed: Herewith

For: Apparatus and Method for Pre-Conditioning CMP Polishing Pad

Attorney Doc. No.: 67,200-1131







Inventor: Chia-Che Chuang Serial No.: To Be Assigned Filed: Herewith

For: Apparatus and Method for Pre-Conditioning CMP Polishing Pad

Attorney Doc. No.: 67,200-1131

